



**ELECTRONIC COPY**

LG806603073  
Report verification at igi.org



May 30, 2026

IGI Report Number **LG806603073**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PRINCESS CUT**

Measurements **7.86 X 7.85 X 5.59 MM**

**GRADING RESULTS**

Carat Weight **3.01 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

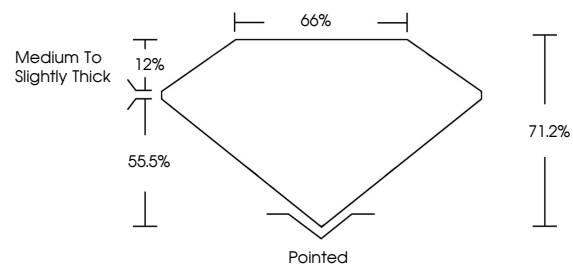
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG806603073**

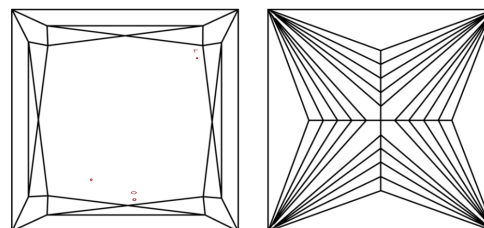
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

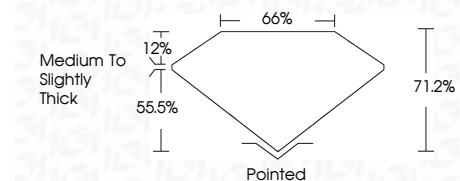
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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**PRINCESS CUT**

**3.01 CARATS**  
E

Carat Weight **3.01**  
Color Grade **E**

Clarity Grade **VS 1**  
Depth **71.2%**  
Table **66%**

Graiss **Medium to Slightly Thick**

Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**

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